

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
CENTRAL FAX CENTER

FEB 23 2004

OFFICIAL

In re Application of

N. Bojarczuk Jr., et al.

Serial No.: 10/059,422

Group Art Unit: 2814

Filed: January 31, 2002

Examiner: Theresa Doan

For: METHOD OF FORMING LATTICE-MATCHED STRUCTURE ON SILICON AND  
STRUCTURE FORMED THEREBYCommissioner for Patents  
Alexandria, VA 22313-1450PETITION AND FEE FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136(a)

Sir:

Applicant hereby petitions for a One-month extension of time to respond to the Office Action mailed October 23, 2003. The One-Month Extension fee of \$110.00 is included in the total fee for filing the R.C.E. for the above-identified application.

The Commissioner is authorized charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0510.

Respectfully submitted,

Date: 2/23/04

McGinn & Gibb, PLLC  
Intellectual Property Law  
8321 Old Courthouse Road, Suite 200  
Vienna, VA 22182-3817  
(703) 761-4100  
Customer No. 21254

  
Phillip E. Miller, Esq.  
Registration No. 46,060

Serial No. 10/059,422  
Docket No. YOR920010368US2

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that I am filing this Request for Continued Examination and Petition and Fee for Extension of Time by facsimile with the United States Patent and Trademark Office to Examiner Theresa Doan, Group Art Unit 2814 at fax number (703) 872-9306 this 23<sup>rd</sup> day of February, 2004.



Phillip E. Miller, Esq.  
Registration No. 46,060